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Enhanced transparent conducting performance of $c$-axis oriented Ca$_3$Co$_4$O$_9$ thin films

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Abstract:

p-type transparent conductive Ca$_3$Co$_4$O$_9$ thin films were grown on LaAlO$_3$ substrate by pulsed laser deposition technique. The films showed perfect $c$-axis orientation with the resistivity of about 7.3 mΩ cm at room temperature and the optical transmittance of about 50% in the visible range. A high figure of merit of about 988 MΩ$^{-1}$ was achieved in these $c$-axis oriented Ca$_3$Co$_4$O$_9$ films, which is comparable to those reported for the state-of-the-art p-type transparent conducting oxides. This work demonstrated the potential applications of $c$-axis oriented Ca$_3$Co$_4$O$_9$ films in optoelectronic devices as a new class of transparent conducting oxide coatings.

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Introduction:

Transparent conducting oxides (TCOs) are electrical conductive materials with a high transparency to visible light. They are widely used as the electrodes or coatings of many optoelectronic devices such as solar cells, light emitting diodes and flat panel displays. The most commonly used TCOs, for example, tin oxide (SnO₂), indium oxide (In₂O₃), indium tin oxide (ITO), and zinc oxide (ZnO), are primarily n-type semiconductors [1-3]. Compared to conventional n-type TCOs, p-type TCOs are generally less conductive and less transparent, and therefore have not been largely commercialized yet. In order to fully explore the novel applications of TCOs in optoelectronic devices, the development of p-type TCOs is critical as well [4]. In the past decade, delafossite compound CuMO₂ (M=Cr, Al, Ga, Fe, Sc, Y), NiO, Cr₂O₃, MoO₃ and etc. have been extensively studied as promising candidates of p-type TCOs [5-11].

R. D. Robinson et al recently demonstrated that the misfit layered cobalt oxide Ca₃Co₄O₉, a class of newly discovered p-type oxide thermoelectric material, exhibited very good transparent conducting performance [12]. Their solution-processed randomly oriented polycrystalline Ca₃Co₄O₉ thin films showed the best figure of merit $FOM$ of about 151 MΩ⁻¹, which was higher than the values reported in literatures for most other p-type TCO thin films. Here, the figure of merit $FOM$ is usually used to evaluate the performance of TCOs and it is defined as $-1/(R_{sh} \times \ln T)$, where $R_{sh}$ is the sheet resistance and $T$ is the average optical transmittance, respectively [10]. It is known that the crystal structure of Ca₃Co₄O₉ consists of the conducting CoO₂ layer
and the insulating $\text{Ca}_2\text{CoO}_3$ layer, which are alternately stacked along the $c$-axis. This layered structure results in a large anisotropy of the electrical transport properties with the $ab$-plane electrical conductivity being much larger than that along the $c$-axis [13]. Moreover, randomly oriented polycrystalline thin films always contain many defects such as grain boundaries and dislocations, which will lead to a small charge carrier mobility and thus a low electrical conductivity [6]. Very recently, Xuebin Zhu et al reported that the solution-processed $c$-axis oriented $\text{Bi}_2\text{Sr}_2\text{Co}_2\text{O}_y$ thin films, another type of misfit layered cobalt oxide with the crystal structure being similar to that of the $\text{Ca}_3\text{Co}_4\text{O}_9$, showed an enhanced $FOM$ in comparison with that of the polycrystalline $\text{Ca}_3\text{Co}_4\text{O}_9$ thin films [14]. This experimental result provided valuable insights on the improvement in the performance of this new class of p-type TCO coatings.

Inspired by the above studies, we report here the significant enhancement in the transport conducting performance of $\text{Ca}_3\text{Co}_4\text{O}_9$ thin films by improving its $c$-axis texture degree. High quality $\text{Ca}_3\text{Co}_4\text{O}_9$ thin films with perfect $c$-axis orientation were successfully grown on $\text{LaAlO}_3$ single crystal substrate by pulsed laser deposition technique. The obtaining films showed a low resistivity of about $7.3 \, \text{m} \Omega \, \text{cm}$ at room temperature and a reasonable optical transmittance of about $50\%$ in the visible range, resulting in a very high figure of merit of $998 \, \text{M} \Omega^{-1}$. This $FOM$ value is almost 6-7 times higher than that of the solution-processed polycrystalline thin film samples and is also comparable to the best values of other p-type TCOs so far reported in literatures [5-11].
Experiments:

c-axis oriented Ca$_3$Co$_4$O$_9$ thin films were grown on single crystal LaAlO$_3$ (001) substrates by pulsed laser ablation of a Ca$_3$Co$_4$O$_9$ ceramic target at the substrate temperature of 680 °C under the oxygen pressure about 40 mtorr. The Ca$_3$Co$_4$O$_9$ target used in this work was synthesized in air using the conventional solid-state reaction method. The commercial CaCO$_3$ (99.5 %, Alfa Aesar) and Co$_3$O$_4$ powders (99.7%, Alfa Aesar) were used as the starting materials. After fully grinding, the mixed powders were calcined at 600 °C for 5 h in air and then pressed into a round pellet ($\phi$=30 mm) under 10 MPa. The pellet was first sintered at 890 °C for 10 h in air with a furnace, and then it was reground, pelleted, and sintered for another 10 h at 890 °C in air. An excimer laser with 308 nm radiation was used for the film deposition with a laser energy density of 1.5 J/cm$^2$ and a repetition rate of 3 Hz. The distance between the target and the substrate was about 50 mm. After deposition, the films were post-annealed at 820 °C for 60 min under the flowing of high-purity oxygen. The crystal structure of the films was measured using a Bruker AXS D8 advance x-ray diffractometer with Cu Kα radiation. The surface morphology of the films was analyzed by scanning electron microscopy (SEM). The microstructure and the elemental compositions of the films were analyzed with a field-emission transmission electron microscopy (TEM, Tecnai G2 F20) equipped with an energy-dispersive x-ray spectroscopy (EDS) detector. Resistivity measurements were performed by using a physical properties measurement system (PPMS, Quantum Design Inc.). The standard four point probe method was used to measure $ab$-plane
resistivity of the Ca$_3$Co$_4$O$_9$ film. To make the ohmic contact, four platinum electrodes (0.5 mm diameter) were deposited onto the films via thermal evaporation. The optical transmission was measured by using a Hitachi UH4150 UV-Visible-NIR spectrophotometer.

**Results and discussion:**

The x-ray diffraction (XRD) $\theta$-2$\theta$ scan curve of a 50 nm-thick Ca$_3$Co$_4$O$_9$ films on LaAlO$_3$ substrates is shown in Fig. 1a. Besides the peaks from LaAlO$_3$ substrate, only peaks from diffractions of (00$l$) Ca$_3$Co$_4$O$_9$ planes are observed, and no diffraction peaks from secondary phases or randomly oriented grains are observed, indicating that the thin films are nearly perfect $c$-axis orientation with pure phase. The $\omega$ scan of the Ca$_3$Co$_4$O$_9$ (004) peak, shown in inset of Fig. 1a, shows a full width at half maximum (FWHM) of 0.21, further confirming the excellent $c$-axis orientation of the film. Fig. 1b is the surface SEM image of the $c$-axis oriented Ca$_3$Co$_4$O$_9$ film. The present film looks much smoother and denser than the corresponding polycrystalline films fabricated by solution method, where micro-scale cracks and nano-scale voids were clearly observed which deteriorated the electrical conductivity as well as the optical transmission of the films [12].

The good crystalline quality and $c$-axis oriented growth of the Ca$_3$Co$_4$O$_9$ thin films were further investigated by TEM. A bright field cross sectional TEM image displayed in Fig. 2a shows that the film is about 50 nm. The selected area electron diffraction (SAED) pattern taken from the film part is shown in the inset of Fig. 2a. The sharp electron diffraction spots with no satellites suggest that the film has good
single crystallinity. Fig. 2b shows the high-resolution TEM image of the Ca$_3$Co$_4$O$_9$ film near the interface. Well-ordered layer structures of Ca$_3$Co$_4$O$_9$ stacked along the $c$ axis can be clearly observed near the interface and everywhere inside the Ca$_3$Co$_4$O$_9$ films. The $c$-axis lattice constant is about 1.08 nm, which is similar to previous results reported by other research groups. In addition, the interface appears very flat, and there is no obvious evidence of secondary phases or any chemical reaction in the interface region over large distances.

Elemental analysis and chemical characterization of the film sample were studied using TEM-EDS. The presence of Ca$_3$Co$_4$O$_9$ with homogeneous distribution of Ca, Co, and O ions has been verified by EDS element mapping, as shown in Fig. 3. No other impurities were detected within the films. The EDS analysis of the inner regions of film reveals that the cation ion ratio of Ca:Co is about 3.00:4.18, which is very close to that of the nominal composition of this material. Moreover, the EDS element mapping also demonstrates that the interface is flat and no obvious interdiffusion occurs between the film and substrate. We also performed the EDS measurement on a large scale of SEM surface image of the present film. It showed the Ca:Co on the film surface was about 3.00:3.90. The Ca:Co ratio on the film surface is slightly larger than that in the inner regions of the film, indicating Ca migration to the film surface.

Fig. 4a shows the temperature dependence of $ab$-plane electrical resistivity ($\rho_{ab}$) of a 50 nm-thick Ca$_3$Co$_4$O$_9$ thin film. The $\rho_{ab}$-$T$ curve of the Ca$_3$Co$_4$O$_9$ film exhibits a broad minimum around 100 K, exhibiting a broad transport crossover from the high-temperature metallic-like regime to the low-temperature insulating-like one. The
increase in the electrical resistivity at low temperature can be attributed to the
decrease of the density of states at Fermi level ($E_F$) with decreasing temperature
below 100 K, and opening an energy gap across $E_F$ at a temperature below 50 K [15,
16]. The room temperature resistivity of this film is about 7.3 m$\Omega$ cm (corresponding
to the surface resistance $R_{sh}$ of about 1460 $\Omega$), which is much smaller than that
reported for the randomly oriented polycrystalline Ca$_3$Co$_4$O$_9$ thin films fabricated by
solution method [12]. The significant improvement in the resistivity of the present
films is mainly due to their perfect $c$-axis orientation, good crystalline quality as well
as dense structures. The carrier type of the Ca$_3$Co$_4$O$_9$ film can be determined by both
Hall measurement or thermopower ($S$) measurement. Hall measurement suggested a
p-type conducting of the Ca$_3$Co$_4$O$_9$ film, and the room temperature carrier density $n$
and mobility $\mu$ of the film was about $4.3 \times 10^{20}$ cm$^{-3}$ and 2.0 cm$^2$V$^{-1}$s$^{-1}$, respectively.
Fig. 4 b is the temperature dependence of the $ab$-plane thermopower ($S_{ab}$) of the $c$-axis
oriented Ca$_3$Co$_4$O$_9$ thin films, which was measured using the PPMS system with a
thermal transport option. The positive $S$ also reveals the major carriers are holes (i.e.
p-type). Moreover, the room temperature $S$ of the $c$-axis oriented Ca$_3$Co$_4$O$_9$ film is
about 120 $\mu$V/K, which is comparable to that of the corresponding single crystals and
is much larger than that reported for polycrystalline thin films, further indicating the
good quality of the present films [12, 17].

Fig. 5a is the transmission spectrum of the bare $c$-axis oriented Ca$_3$Co$_4$O$_9$ thin
film after subtracting the contribution of LaAlO$_3$ substrate. With the increase of photo
wavelength, the optical transmittance of the film increases and is greatly enhanced in
the infrared region. Similar behavior was observed in the corresponding polycrystalline Ca$_3$Co$_4$O$_9$ thin films [12]. The average optical transmittance ($T$) of the film in the visible range, estimated with the same photon energies as Ref. 12 (i.e. $E=1.77, 2.0, 2.25, 2.48, 2.75, 3$ eV), is about 50%. The inset of Fig. 5a shows the photography of the $c$-axis oriented Ca$_3$Co$_4$O$_9$ film sample on a labeled paper. It is clearly seen that the film is visibly transparent. We also estimated the optical band gap $E_g$ of the present $c$-axis oriented Ca$_3$Co$_4$O$_9$ thin film by using the equation of $\alpha h\nu = A(h\nu-E_g)^m$, here $\alpha$ is the optical absorption coefficient, $h\nu$ is the photon energy, $A$ is a constant, $m$ is 1/2 for a direct band transition and $m$ is 2 for an indirect band transition. A linear relationship between $(\alpha h\nu)^2$ and $h\nu$, as shown in Fig. 5b, suggests a direct energy band gap of the Ca$_3$Co$_4$O$_9$ film. The optical band gap width of the Ca$_3$Co$_4$O$_9$ films is estimated to be about 2.1eV according to the fitting results, which is same as the value obtained from the Ca$_3$Co$_4$O$_9$ ceramic samples ($E_g=2.1$ eV) [18]. It should be mentioned here that the band gap Ca$_3$Co$_4$O$_9$ is just in the range of blue/violet side of the visible spectrum. Such a compound would for sure absorb a good portion of visible light and by its nature not a good TCO. However, we still believe there is some potential to optimize the optical transmittance of this compound. For example, by doping.

To evaluate the transparent conducting performance of the $c$-axis oriented Ca$_3$Co$_4$O$_9$ thin films, we calculated the figure of merit $FOM$ according to the equation of $FOM = -1/(R_{sh} \times \ln T)$. It should be mentioned here that although both optical transmission $T$ and sheet resistance $R_{sh}$ of a TCO film increase with decreasing the
film thickness $d$ as expressed by $T = e^{-ad}$ and $R_{sh} = 1/(\sigma d)$, the FOM value ($FOM = \sigma/\alpha$) of the film almost does not depend on the film thickness (assuming fixed $\rho$ and $\alpha$) [12, 19]. However, if the film is too thin (for this work, if the Ca$_3$Co$_4$O$_9$ film thickness is decreased to about 30 nm), the electrical conductivity $\sigma$ of the film will decrease strongly with the decrease of film thickness due to the surface scattering, leading to an obvious deterioration in the optoelectronic properties of the film [20]. Detailed works on the relationship between the Ca$_3$Co$_4$O$_9$ film thickness (microstructure, doping, etc) and its optoelectronic properties are required in our future work. The $FOM$ of the present 50 nm-thick $c$-axis oriented Ca$_3$Co$_4$O$_9$ films is calculated to be as high as 988 M$\Omega^{-1}$, which is almost 6-7 times higher than that reported for the corresponding polycrystalline Ca$_3$Co$_4$O$_9$ thin films and is comparable to state-of-the-art p-type TCOs reported so far in literatures [5-12, 14].

Conclusion:

Single-phase, $c$-axis oriented Ca$_3$Co$_4$O$_9$ thin films were fabricated by pulsed laser deposition on LaAlO$_3$ substrate. The resulting Ca$_3$Co$_4$O$_9$ films were smooth and dense with very good crystalline quality. The room temperature resistivity of the films is about 7.3 m$\Omega$ cm and the average optical transmittance in the visible range of about 50 %. A very high figure of merit ($FOM$) of 998 M$\Omega^{-1}$ was achieved in the $c$-axis oriented Ca$_3$Co$_4$O$_9$ thin film, which is comparable to the best values reported for other p-type TCOs. This work opens up new strategy toward the practical applications of Ca$_3$Co$_4$O$_9$ films as a promising p-type TCO coatings.

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**References:**


**Figure captions:**

Fig. 1. (a) XRD $\theta$-$2\theta$ scan of a 50-nm thick Ca$_3$Co$_4$O$_9$ thin film on LaAlO$_3$ substrate; (b) SEM surface image of Ca$_3$Co$_4$O$_9$ thin film.

Fig. 2 (a) TEM and (b) high resolution TEM of Ca$_3$Co$_4$O$_9$/LaAlO$_3$ (LAO) interface. The inset of Fig. 2a is the SAED pattern taken from the film part. The location of the CoO$_2$ layers is indicated by red lines in Fig. 2b, while the Ca$_2$CoO$_3$ layer locates between the two adjacent CoO$_2$ layers.

Fig. 3. TEM-EDS map of Ca$_3$Co$_4$O$_9$ thin film on LaAlO$_3$ substrate.

Fig. 4 The temperature dependence of $ab$-plane (a) resistivity, and (c) thermopower for a 50 nm-thick Ca$_3$Co$_4$O$_9$ thin film on LaAlO$_3$ substrate.

Fig. 5 (a) the transmittance spectra of a 50 nm-thick Ca$_3$Co$_4$O$_9$ thin film after abstracting the substrate contribution. the inst is the photography of this Ca$_3$Co$_4$O$_9$ thin film on a labeled paper; (b) $(\alpha h\nu)^2$ versus $h\nu$ plot of Ca$_3$Co$_4$O$_9$ thin film.
Fig. 1

(a) X-ray diffraction pattern showing the intensity (a.u.) as a function of 2θ (degree) with peaks labeled for LAO (001) to LAO (008). The inset provides a zoomed view of the low angle region.

(b) Scanning electron microscopy image with a scale bar of 500 nm.
Fig. 2
Fig. 4

(a) Graph showing $\rho_{ab}$ (m$\Omega$.cm) vs. $T$ (K)

(b) Graph showing $S_{ab}$ (µV/K) vs. $T$ (K)
Fig. 5

(a) Transmittance (%) vs. Wavelength (nm)

(b) $(\alpha h\nu^2)$ vs. $h\nu$ (eV) with a value of 2.1 eV indicated.